Accepted Manuscript

Moritz Heintze, Ioana Luciu

Nodule formation on sputtering targets: Causes and their control by MF power supplies

PII: S0257-8972(17)30895-2

DOI: doi: 10.1016/j.surfcoat.2017.09.009

Reference: SCT 22646

To appear in: Surface & Coatings Technology

Received date: 20 June 2017

Revised date: 1 September 2017 Accepted date: 3 September 2017

Please cite this article as: Moritz Heintze, Ioana Luciu, Nodule formation on sputtering targets: Causes and their control by MF power supplies, *Surface & Coatings Technology* (2017), doi: 10.1016/j.surfcoat.2017.09.009

This is a PDF file of an unedited manuscript that has been accepted for publication. As a service to our customers we are providing this early version of the manuscript. The manuscript will undergo copyediting, typesetting, and review of the resulting proof before it is published in its final form. Please note that during the production process errors may be discovered which could affect the content, and all legal disclaimers that apply to the journal pertain.



ACCEPTED MANUSCRIPT

Nodule formation on sputtering targets: Causes and their control by MF power supplies.

Moritz Heintze (corresponding author), Ioana Luciu

TRUMPF Hüttinger GmbH + Co. KG, Freiburg, Germany

Phone: +49 (0)761 8971-5374

moritz.heintze@de.trumpf.com

Download English Version:

https://daneshyari.com/en/article/8024262

Download Persian Version:

https://daneshyari.com/article/8024262

<u>Daneshyari.com</u>